

## INFORMATION DISCLOSURE CITATION

Atty. Docket No.	04329.3133	Serial No.	
Applicant	Masahiko HASUNUMA et al.		
Filing Date	September 3, 2003	Group:	

U.S. PATENT DOCUMENTS							
Examiner Initial*		Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
DHL		6,037,668	03/14/2000	Cave et al.			

FOREIGN PATENT DOCUMENTS							
		Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
DHL		11-176835	07/02/1999	Japan			No
		11-307633	11/05/1999	Japan			No
		2001-267323	09/28/2001	Japan			No
		2001-196372	07/19/2001	Japan			No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
DHL	Kurashima et al; "SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD"; U.S. Patent Application No. 10/640,004, filed August 14, 2003

Examiner	Kang, Donghee	Date Considered	11-27-04
*Examiner:	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		
Form PTO 1449		Patent and Trademark Office - U.S. Department of Commerce	